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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

44

APPL NUM 10006967	FILING DATE 12/05/2001	CLASS 438	SUBCLASS 460	GAU 2842	EXAMINER 2822
**APPLICANTS: Felton Lawrence; Luo Jing; <i>u-Pi Cardat</i>					
**CONTINUING DATA VERIFIED: THIS APPLN CLAIMS BENEFIT OF 60/251,287 12/05/2000 AND CLAIMS BENEFIT OF 60/251,288 12/05/2000 <i>W</i>					
** FOREIGN APPLICATIONS VERIFIED: <i>24</i>					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO 5721.1	
Verified and Acknowledged Examiners's initials <i>Zin</i>					
TITLE : Method and device for protecting micro electromechanical systems structures during dicing of a wafer					
U.S. DEPT. OF COMM./PAT & TM-PTO-436L(Rev. 12-04)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Total Claims	
		Print Claim for O.G.	
		Sheets Drwg.	
		Figs. Drwg.	
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	
		Application Examiner	
		PREPARED FOR ISSUE	
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